

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Basol et al.  
Appl. No. : 10/822,424  
Filed : April 12, 2004  
For : SYSTEM FOR  
ELECTROPOLISHING AND  
ELECTROCHEMICAL  
MECHANICAL POLISHING  
Examiner : Zulmariam Mendez  
Group Art Unit : 1709  
Confirmation No. : 4984

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April 21, 2008

(Date)



Adam Gilbert, Reg. No. 59,967

**AMENDMENT AND RESPONSE TO OFFICE ACTION DATED JANUARY 22, 2008****Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Madam:

In response to the Office Action dated January 22, 2008, the Applicants respectfully request that the Examiner reconsider the above-identified patent application in view of the following amendments and remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.